

U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
		AM-1622.D1	unknown
LIST OF RELEVANT ART CITED BY APPLICANT		Applicant	
(Use several sheets if necessary)		Hong Shih et al.	
		Filing Date	Group
		January 21, 2000	unknown

U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AH							
	AJ							
	AK							
	AL							
	AM							
	AN							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AO	Shaffer, "Engineering Properties of Carbides," <i>Engineered Materials Handbook</i> , vol. 4, "Ceramics and Glasses" (Materials Information Society, 1991), pp. 804-807, 843, 844
AP	Linke et al., "Behavior of Boron Doped Graphites, Plasma Sprayed Boron Carbides and a-C/B:H as Plasma Facing Material," <i>J. Fusion Technology</i>
AQ	
AR	

Examiner	Date Considered
<i>[Signature]</i>	<i>November 20, 2000</i>

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.